High Broad-Band Photoresponsivity of Mechanically Formed InSe–Graphene van der Waals Heterostructures

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The development of van der Waals (vdW) heterostructures fabricated by mechanically stacking 2D crystals has led to the discovery of fundamental physical phenomena and to the realization of 2D functional devices ranging from sensitive phototransistors to tunnel diodes.\textsuperscript{[1–13]} The electronic properties of these devices can be modified not only by careful selection of the materials within the stack, but also by adjusting the built-in strain and relative orientation of the component crystalline layers. Among the vdW crystals, the metal chalcogenide III–VI compound, InSe, represents an exfoliable and stable semiconductor that extends the library of vdW crystals. In its bulk form, InSe has a direct bandgap $E_g = 1.26$ eV at $T = 300$ K, which can be increased due to quantum confinement by reducing the number of atomic layers in the crystalline sheet.\textsuperscript{[14–17]} Recent reports of bendable photodetectors,\textsuperscript{[18]} large-scale image sensors,\textsuperscript{[19]} electroluminescence in p–n junctions,\textsuperscript{[20]} and field-effect transistors (FETs) with large current on/off ratios ($\approx 10^6$) and high carrier mobilities ($\mu = 0.1$ m$^2$ V$^{-1}$ s$^{-1}$) at room temperature\textsuperscript{[21]} have demonstrated the potential of InSe for future technologies.

This burgeoning research field is still in its infancy and offers exciting opportunities for discoveries and the realization of functional devices that implement InSe in combination with other vdW crystals. Crucial to these future developments is the formation of good interfaces and Ohmic contacts to the optically active InSe layer. Devices currently used are mostly prepared from InSe with metal contacts.\textsuperscript{[14,20–22]} On the other hand, the stability, flexibility, strength, high conductivity, and weak optical absorbance of graphene make this single atomic carbon layer a particularly attractive option for use as a transparent electrical contact. Furthermore, the work function of graphene can be adjusted by the electric field effect,\textsuperscript{[23]} offering exciting opportunities for device operation and adjustable band alignment at an interface with a layered compound.

Here, we report on van der Waals graphene/InSe heterostructures formed by mechanical contact due to attractive vdW forces at the graphene/InSe interface. We exploit the broad-band transparency of graphene and the favorable band line up of graphene with InSe to create high-performance photodetectors. We demonstrate vertical and planar graphene–InSe–graphene heterostructures with a high photoresponsivity (up to $\approx 10^4$ A W$^{-1}$ at $\lambda = 633$ nm), not yet achieved in other 2D vdW crystals, and with a spectral response that extends from the near-infrared to the visible spectrum. The highest photoresponsivity is observed in device architectures where the InSe and graphene layers are vertically stacked and an optical window is created by overlapping the two graphene electrodes, thus enabling sensitive photodetection. These heterostructures provide innovative device architectures that enable access to fast electron speeds and high broad-band spectral response.

Our InSe crystals were grown using the Bridgman method from a polycrystalline melt of In$_{1.03}$Se$_{0.97}$. The $\gamma$-polypeptide crystal structure of InSe was probed by X-ray diffraction (XRD) using a DRON-3 X-ray diffractometer in a monochromatic Cu–K$_\alpha$ radiation of wavelength $\lambda = 1.5418$ Å. The primitive unit cell contains three InSe layers each of which has a thickness of 8.320 Å and consists of four covalently bonded monoatomic sheets in the sequence Se-In-In-Se; along the $a$–$b$ plane, the primitive unit cell has a lattice constant of $c = 24.961$ Å and, within each $a$–$b$ plane, atoms form hexagons with lattice parameter $a = 4.002$ Å. In its bulk form, InSe contains native donors due to In-interstitial atoms.\textsuperscript{[24]} From Hall effect measurements on bulk InSe at $T = 300$ K, we obtain an electron density $n = 10^{21}$ m$^{-3}$, an electron mobility $\mu = 0.1$ m$^2$ V$^{-1}$ s$^{-1}$, and a Fermi energy $E_F = 0.21$ eV below the conduction band minimum.

The InSe nanosheets were prepared from the as-grown crystals by mechanical exfoliation using adhesive tape and...
have thicknesses $t$ that range from 20 to $\approx 100$ nm, over which InSe retains a direct bandgap $E_g$ and a relatively high electron mobility $(10^{-2}-10^{-1}$ $\text{m}^2\text{V}^{-1}\text{s}^{-1})$.\(^{21,22}\) The exfoliated InSe flakes were then integrated into planar and vertical device structures incorporating graphene electrodes. We first focus on the planar devices: a graphene layer, grown on a copper substrate by low-pressure chemical vapor deposition (CVD), was transferred onto a SiO$_2$/Si substrate and patterned by electron beam lithography (EBL) into two contacts prior to the transfer of an InSe nanoflake (see the Experimental Section for details of the device fabrication). Figure 1a illustrates the schematic layered structure and an optical image of a graphene–InSe–graphene device. Figure 1b illustrates the schematic layered structure and an optical image of a graphene–InSe–graphene device. Figure 1c illustrates the schematic layered structure and an optical image of a graphene–InSe–graphene device.

As shown in Figure 1b, the current through the InSe flake has a linear dependence on the bias voltage $V_s$ applied between the two graphene electrodes. The $I$–$V_s$ characteristics are symmetric relative to negative and positive values of $V_s$ and, for each $V_s$, the current increases with increasing gate voltage $V_g$. Separate Au-contacts on each graphene layer enable us to assess their conductivity: they exhibit a linear dependence of the current on the bias voltage and a minimum conductance at around a gate voltage $V_g = 60$ V, corresponding to p-type doping and hole concentration of $p = 5 \times 10^{12}$ $\text{cm}^{-2}$, typical for CVD graphene (inset of Figure 1b).\(^{23}\) The transport characteristics of the device are reproducible and stable; also, a fast response time is observed with a cut-off frequency of $f = 10^4$ Hz. Figure 1c shows the characteristic temporal dependence of the current modulated at a frequency of $f = 0$ Hz.

The linearity and symmetry of the $I$–$V_s$ characteristics are preserved under optical illumination, see Figure 2a. The spatially resolved photocurrent map obtained by scanning a focused laser beam across the plane of the graphene/InSe/graphene device shows that photocurrent generation occurs primarily in the InSe region of the flake between the two graphene electrodes, $g_1$ and $g_2$. This is measured using separate Au-contacts on each graphene layer under an applied bias of 0.1 V. \(\approx 0.1 V\) in the dark current modulated by an AC square bias $V_s$ with a laser at $\lambda = 633$ nm. c) Temporal dependence of the photocurrent $\Delta I_s$ vs. $V_s$ with a laser at $\lambda = 633$ nm. The inset shows a color map of $\Delta I_s$ versus $V_s$ and $V_g$, with a laser at $\lambda = 633$ nm. c) Temporal dependence of the photocurrent $\Delta I_s$ vs. $V_s$ with a laser at $\lambda = 633$ nm. The dashed line shows the modulation of the laser beam at frequency $f = 100$ Hz.

Figure 1. a) Optical image and schematic structure of a graphene–InSe–graphene planar device on a gated SiO$_2$/Si substrate. b) Current–voltage, $I$–$V_s$, characteristics in the dark at $T = 300$ K at various gate voltages, $V_g$. The inset shows the $V_s$-dependence of the current through each graphene electrode, $g_1$ and $g_2$. This is measured using separate Au-contacts on each graphene layer under an applied bias of 0.1 V. c) Temporal dependence of the dark current modulated by an AC square bias $V_s$ signal of frequency $f = 100$ Hz and amplitude of 1 V ($V_g = 0$ V).

Figure 2. a) Photocurrent $\Delta I_s$ versus $V_g$ at $T = 300$ K and $V_s = 0$ V under light illumination with a focused laser beam of power $P$, 10$^0 P$, 10$^1 P$, and 10$^2 P$ ($P = 0.5$ $\text{nW}$, $\lambda = 633$ nm). The inset shows the photocurrent map indicating that $\Delta I_s$ arises primarily from the InSe layer between the two graphene electrodes, $g_1$ and $g_2$. b) Photoconductivity spectra at $T = 300$ K and $V_s = 2$ V with unfocused light and power $P = 10$ $\text{pW}$. The inset shows a color map of $\Delta I_s$ versus $V_s$ and $V_g$, with a laser at $\lambda = 633$ nm. c) Temporal dependence of the photocurrent $\Delta I_s$ with a laser at $\lambda = 633$ nm. The dashed line shows the modulation of the laser beam at frequency $f = 100$ Hz.
graphene electrodes (see the inset of Figure 2a). A broad-band spectral response from the near-infrared to the visible parts of the spectrum is observed under focussed optical illumination, see Figure 2b. The photoinduced current, \( \Delta I \), is weakly modulated by the gate voltage \( V_g \) and its dependence on \( V_g \) is opposite to that observed for the dark current, i.e., \( \Delta I \) decreases with increasing \( V_g \) from \(-60\) to \(+60\) V. As shown in Figure 2c, the temporal dependence of \( \Delta I \) is slower than that of the dark current with a rise time \( \tau_r \approx 1\) ms and decay time \( \tau_d \approx 10\) ms, which are not affected by \( V_g \).

High-quality interfaces, crystal lattice alignment and control over the relative band alignment are essential for tuning and controlling electrical injection of carriers from an electrode into a semiconductor layer. The cleaved facets of InSe layered crystals are atomically smooth, as confirmed by our atomic force and transmission electron microscopy studies (not shown), and contain a low-density of surface states which makes the surface of this material stable compared to covalent semiconductors, such as Si; this also enables the formation of abrupt heterointerfaces when InSe is combined with metals and/or other layered compounds.

As shown in Figure 3a, the electron affinity of graphene \( \phi_g = -4.5\) eV is larger than that of bulk InSe \( \phi_{\text{InSe}} = -4.6\) eV. Furthermore, the graphene work function \( \phi_g \) can be increased relative to that of n-type InSe \( \phi_{\text{InSe}} = -4.81\) eV by applying a gate voltage. Compared to InSe, this gate effect is stronger in graphene due to the low density of states of graphene, compared to \( \phi_{\text{InSe}} \), with the Fermi level increasing from ca. \(-0.3\) eV to \(-4.85\) eV at \( V_g = -60\) V to \( 0\) eV \( \phi_g = -4.5\) eV at \( V_g = +60\) V relative to the neutrality point of the Dirac cones. Thus, we infer that at equilibrium, electrons tend to transfer from graphene to InSe where they can form an accumulation layer at the interface with graphene (Figure 3b). This alignment of the bands at each graphene/InSe interface facilitates the formation of an Ohmic contact, consistent with the linearity of the measured \( I-V \) (see Figure 1b).

The band alignment is supported by the opposite dependence on the applied gate bias observed for the dark current and the photocurrent. To explain the monotonous increase of the dark current with increasing \( V_g \) (Figure 1b) and the decrease observed for the photocurrent (Figure 2b), we should examine the modulation of the electronic conduction by the gate voltage. As shown in Figure 3b, for a positive gate voltage \( V_g > 0 \), the Fermi level in graphene moves upward toward the Dirac point and more electrons can diffuse into InSe, thus decreasing the effective length \( l \) over which the bias \( V_s \) is dropped; in contrast, for \( V_g < 0 \), the Fermi level in graphene moves to lower energies, closer to the Fermi energy of InSe, and electrons retreat from InSe thus increasing \( l \). Thus for \( V_g < 0 \), the length \( l \) is longer than for \( V_g > 0 \); correspondingly, the dark current decreases as \( V_g \) is made more negative, but the photocurrent increases due to an increased number of carriers photogenerated over a larger length \( l \). From the change of the photocurrent (ca. \( \pm 20\% \)) over the range of \( V_g \) from \(-60\) to \(+60\) V, we estimate that \( l \) changes by ca. \( \pm 20\% \). This dependence was not observed in the Au–InSe–Au planar devices where the dark current and photocurrent both decrease or increase with varying the gate voltage.

Under an applied bias \( V_g \), electrons and holes that are photoexcited in InSe are swept by the electric field in opposite directions and are extracted at the graphene electrodes to generate a photocurrent \( \Delta I = \frac{[\epsilon \alpha P]}{hv} \times \frac{1}{\tau_r/\tau_d} \), where \( P \) is the incident power, \( \alpha \) is the absorption coefficient of InSe at the photon energy \( h\nu \), \( \epsilon \) is the electron charge, \( t \) is the thickness of the InSe layer, and \( \tau_r/\tau_d \),
is the ratio of the minority carrier lifetime ($\tau_m$) and transit time ($\tau_t$) of electrons in InSe (for the derivation for $\Delta t$, see Section S1, Supporting Information). Thus the photoresponsivity $R$ of our device can be approximately described by $R = \Delta I / P = [\sigma \alpha V_0 \tau_m / \tau_t]$. Furthermore, we can express the external and internal quantum efficiencies as $\eta_{QE} = R[h\nu/e] = [\sigma \alpha V_0 \tau_m / \tau_t]$ and $\eta_0 = \eta / \eta_{QE}$, respectively. These relations indicate that large values of $R$, $\eta_{QE}$, and $\eta_0$ can be achieved if the lifetime of the minority carriers (holes) is longer than the transit time of electrons.

Figure 4a shows the measured photoresponsivity at $V_g = 2 \, V$, $V_e = 0 \, V$, and $\lambda = 633 \, nm$: $R$ is strongly dependent on the optical power $P$ and reaches a maximum value of $R = 4 \times 10^3 \, A / W$ at the lowest incident power $P = 10 \, pW$, which corresponds to $\tau_t / \tau_m = 3 \times 10^4$ for $\alpha = 10^9 \, m^{-1}$ at $h\nu = 1.96 \, eV$ ($\lambda = 633 \, nm$) and $\tau = 30 \, nm$. From the measured values of $R$, we estimate a maximum external quantum efficiency $\eta_{QE} = R[h\nu/e] = 5 \times 10^3$ and a specific detectivity $D^* = R(A/2e)^{1/2} \approx 10^{10} \, m^2\, W^{-1}\, s^{-1/2}$, where $A = 20 \, \mu m^2$ is the area of the device and $I = 0.6 \times 10^3 \, A$ is the dark current at $V_e = 2 \, V$ and $V_g = 0 \, V$. As shown in Figure 2b, the photoresponse depends on the photon energy and we estimate that $R$ and $\eta_{QE}$ decrease by a factor of $\approx 30$ and 50, respectively, for $h\nu$ decreasing from $\approx 2$ to $1.3 \, eV$.

The decrease of $R$ with increasing $P$ is analogous to the $P$-dependence reported previously for the photoresponsivity of other graphene-based photodetectors.[4] According to our model, the photoresponsivity is determined by the ratio $\tau_t / \tau_m$. Thus the decrease of $R$ with increasing $P$ suggests a decrease of $\tau_t$ and/or an increase of $\tau_m$. The transit time of photoinduced carriers can be increased by the power due to enhanced scattering.[28] Also, an increasing power can induce Auger recombination processes and increases the carrier recombination rate, thus reducing $\tau_t$. Since this behavior is not observed in devices based on thick bulk InSe flakes, we infer that Auger-like carrier recombination on traps is enhanced in these 2D vdW crystals due to stronger Coulomb interactions. Finally, $R$ decreases linearly with decreasing applied bias voltage $V_g$. For example, the increase in the electron transit time $\tau_t = \sqrt{\mu V_e I}$ for $V_e = 2 \, V$, $I = 2 \, \mu A$, and $\mu = 0.1 \, m^2 / V \cdot s$, we estimate a transit time $\tau_t \approx 2 \times 10^{-11} \, s$ and a carrier lifetime $\tau_m \approx 5 \times 10^{-6} \, s$.

Our values of $R$ and $\eta_{QE}$ for the InSe/graphene photodetector are significantly larger (by a factor of $10^6$) than those measured in devices in which Au-read contacts replace the two graphene electrodes on the InSe flake, see Figure 4a. We attribute the lower photoresponsivity in the Au–InSe–Au heterostructure to the presence of a Schottky barrier at the Au/n-type InSe interface (inset of Figure 4a). As shown in Figure 4b, this could form because the work function for Au ($\phi_{Au} = -5.2 \, eV$) is lower than that for n-InSe ($\phi_{InSe} = -4.8 \, eV$), thus resulting in a Schottky contact at each interface of the heterostructure and in nonlinear $I-V_g$ (not shown). A barrier may also form due to a defective interface between InSe and the metal contact, as reported recently by Feng et al.[22]

Our data show that the graphene electrodes enable an efficient extraction of photogenerated carriers in n-InSe. Since graphene is optically transparent, high photoresponsivity can also be achieved in multilayer systems where the InSe and graphene layers are vertically stacked with the top graphene layer acting as a broad-band optical window. These structures have the additional advantage that the separation of the graphene electrodes, determined by the thickness $t$ of the InSe flake, is smaller leading to a more sensitive photodetector through a decrease of the carrier transit time. However, compared to the planar devices, for the fabrication of the vertical graphene/n-InSe/graphene structure, additional process steps are required to pattern the upper graphene contact layer. Here we have developed different processing steps, corresponding to devices architectures of type A (Figure 5a) and type B (Figure 5b and Figure S2, Supporting Information), which make use of exfoliated-graphene and graphene grown by CVD, respectively (see the Experimental Section and Section S2, Supporting Information for details of the device fabrication).

Figure 5c shows optical images of device A. Here the top $(g_t)$ and bottom-graphene $(g_b)$ layers overlap an InSe nanoflake of thickness $t = 27 \, nm$. The size of the optical window on the top surface of the InSe is approximately $4 \, \mu m \times 4 \, \mu m$ (see square in Figure 5c) and corresponds to the region of the InSe flake whose optical excitation generates a photocurrent. As shown in Figure 5c, the dependence of the dark current, $I_d$, on the applied bias $V_g$ is non-linear. This behavior, which is different from that observed for the planar device (Figure 2), may arise from a spurious contact resistance at the InSe/graphene interface caused by surface defects or residual organic material introduced during the fabrication process (see discussion in the Experimental Section).

Devices of type A and B exhibit a stable and reproducible photoresponsivity (Figure 5d) with values of $R$ of up to $10^5 \, A / W$ at $\lambda = 633 \, nm$ and response to light at powers $P$ as low as $10^{-14} \, W$ over an area of the InSe flake of $16 \, \mu m^2$ for device A (see photocurrent map in the inset of Figure 5d). From this value of $R$, we estimate an external quantum efficiency $\eta_{QE} = R[h\nu/e] = 10^5$ and a specific detectivity $D^* = R(A/2e)^{1/2} \approx 10^{13} \, m^2\, W^{-1}\, s^{-1/2}$, where $A = 16 \, \mu m^2$ is the area of the device and $I_d = 0.4 \times 10^{-9} \, A$ is the dark current at $V_e = 2 \, V$ and $V_g = 0 \, V$. Finally, we note that a power law relation of the form $R \propto P^n$, with $n = 0.7$ where $C$ is a constant, provides a good empirical fit to data of $R$ for both vertical (see dashed line in Figure 5d) and planar heterostructures.
thickness type B (magenta). Devices B 1 and B 2 are based on InSe flakes of thickness contrast, transition metal dichalcogenides, such as MoS 2 , have semiconductor down to thicknesses of a few nanometers. In a direct-bandgap only in the monolayer form. \[ 29 \] Also, we note that although a higher photoresponsivity (10 7 A W \(-1\) achieved in phototransistors based on graphene and colloidal MoS 2 , WS 2 reported recently, and InSe remains a direct-gap nanocrystals.[39] the performance of such hybrid photodetectors tends to be compromised by a slow (\(1 s\)) optical response due to the slow escape rate of photogenerated charges from the strongly confined nanocrystals. In contrast, for our 2D structures, the mechanism responsible for the photore- sponse does not rely on a charge trapping effect as light generates free carriers; in addition, the extraction of both electrons and holes at the graphene electrodes is facilitated by a low potential barrier at each InSe/graphene interface. These features of our heterostructures enable relatively fast transit times for carriers and modulation of the dark and photocurrent at millisecond time scales.

In summary, our findings demonstrate that mechanically formed heterojunctions of InSe and graphene have optical and electrical properties with potential for applications in optoelectronics. Our innovative fabrication methods could be extended to other material systems and device architectures. It should be possible to achieve different band alignments and potential profiles by combining InSe with other layered semiconductors, and by selecting the doping, n- or p-type, of the component layers, which is difficult to achieve in other van der Waals 2D crystals. For example, further developments include systems in which the InSe layer is replaced by multiple bandgap heterostructures, such as InSe/GaSe or InSe/ hBN junctions and quantum wells. This type of vertical heterostructure architecture would enable fast electron speeds; photonic applications are also attractive due to the potential to access an even wider spectral range than that achieved in our current devices.

**Experimental Section**

Images of the InSe flake and graphene topography were acquired by atomic force microscopy (AFM) in noncontact mode under ambient conditions. The experimental setup for the photocurrent maps comprised a He–Ne laser (\(\lambda = 633\) nm), an XY linear positioning stage and an optical confocal microscope system. The laser beam was focused to a diameter \(d = 1 \mu m\) using a 100X objective and the maps were measured at low power (\(P < 0.1\) mW) to avoid lattice heating.

For the measurement of the photocurrent spectra (Figure 2b), light from a 250 W quartz halogen lamp was dispersed through a 0.25 m monochromator (bandwidth of ~10 nm). Light was modulated with a mechanical chopper (frequency \(f = 7\) Hz) and focused onto the device. The photocurrent signal was measured using a Stanford SR830 lock-in amplifier (integration time constant of \(t = 3\) s).

The measurements of the DC dark current and photocurrent versus the applied voltage (Figures 1b and 2a) were made using a Keithley 2400 source-meter. For the temporal studies of the dark current (Figure 1c), we used a TTI TGA 1241 arbitrary waveform generator and a Tektronix DPO 4032 digital oscilloscope. The response of the dark

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**Figure 5.** Schematic structure of graphene–n-InSe–graphene vertical devices of a) type A and b) type B. c) Left: Optical images of device A showing the heterostructure before and after deposition of the Au-contacts. The graphene layers, g 1 and g 2 , are separated by an InSe flake of thickness \(t = 27\) nm and overlap over a small region shown by the square. Right: Dark current, \(I\), and photocurrent, \(\Delta I\), versus \(V_s\) at \(T = 300\) K for device A. The photocurrent is measured with a laser beam of power \(P\), 10 P, 100 P, and 1000 P (\(P = 40\) mW, \(\lambda = 633\) nm, \(T = 300\) K). d) Photo- responsivity versus laser power at \(T = 300\) K and \(\lambda = 633\) nm for device A (blue) and devices of type B (magenta). Devices B 1 and B 2 are based on InSe flakes of thickness \(t = 130\) and 80 nm, respectively. The line is a fit to data for device A by an empirical power law, i.e., \(R = P^n\), where \(n = 2/3\). The inset shows a photocurrent map superimposed onto the optical image of device A.
current to an AC square driving signal was studied in the frequency range $f = 10^{-1}$–$10^3$ Hz. The temporal dynamics of the photocurrent (Figure 2c) was investigated under constant bias voltage ($V = \pm 1$ V) and illumination by a mechanically modulated He–Ne laser with $\lambda = 633$ nm, $P = 10^{-2}$ W cm$^{-2}$ and frequency $f$ in the range 1–400 Hz. The photocurrent signal was measured using a Tektronix DPO 4032 digital oscilloscope and a Keithley2400 was used as a DC voltage source. For these AC measurements, the device was connected in a low series with a 1 MΩ resistor. We measured the voltage drop across the resistor, which enabled us to measure voltage signals with a low noise level.

**Fabrication of Planar Graphene/InSe Heterostructures:** The exfoliated InSe flakes were integrated into 2D planar structures incorporating either Au or graphene contacts fabricated by EBL. In these devices, CVD graphene, grown on a copper substrate, was transferred and patterned and etched in an Ar/O$_2$ plasma to leave a graphene strip, which was deposited in a later fabrication step (see below). An isolation layer formed by exposing a negative resist, AR-N, using electron beam lithography was then formed; this covered the edges of the InSe flake and the regions of the lower graphene contact close to the flake, to avoid the formation of electrical shorts between upper and lower graphene strips. A window with an area of approximately 2 µm $\times$ 2 µm was formed in the AR-N layer on the top surface of the InSe to facilitate the mechanical contact with the upper graphene layer. Finally, a second layer of graphene was transferred as described above; in this case the supporting PMMA film, which was added to the graphene/copper before etching in FeCl$_3$, was not removed, but instead used as the resist layer in a further stage of electron beam lithography in which the upper graphene contact strip was defined by etching in an Ar/O$_2$ plasma. The resulting upper contact runs at right angles to the lower strip to form a graphene/InSe/graphene vertical heterostructure and overlaps the Au/Ti contact pads formed at an earlier stage of the process (see Figure S2, Supporting Information).

The non-linearity of the I(V) characteristics of the devices A and B is possibly related to the inclusion of organic residues at the graphene/InSe interface. This may arise from polymeric layers used during the process (including the negative resist layer for type B devices); in addition the InSe layer is submerged in water during the transfer of the upper graphene contact.

**Supporting Information**

Supporting Information is available from the Wiley Online Library or from the author.

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